## Laboratories

(2) Wentworth

## www.wentworthlabs.com



PEGASUS ${ }^{\text {TM }}$ S200 FEATURES

High Speed XY motion for high throughput and flexible speed control.

Precision engineering for reliable and repeatable sub-micron probing.

Adaptable for industry standard testers.
Accurate advanced controller software

Customizable product enhancing hardware and software options.

Easy Maintenance using sophisticated system diagnostics.

Wide range of product enhancing accessories.
Robust mechanical design.

## ACCURATE, COST EFFECTIVE PROBING WITH PEGASUSTM



## RAPID PROBING WITH TUNEABLE SPEEDS AND PRODUCT ENHANCING ACCESSORIES ALLOW FOR FAST PROBING AND INCREASED THROUGH-PUT.

PEGASUS PROBE, HEIGHT DETECTION AND VARIABLE CONTACT FORCE ADJUSTMENT MAKES IT EASY TO OBTAIN THE DESIRED PROBE MARK


Pegasus ${ }^{\text {TM }}$ S200 with Pegasus Probe ${ }^{\text {TM }}$


Pegasus ${ }^{\text {TM }}$ Controller

## SPEED \& FLEXABILITY

Pegasus ${ }^{T M}$ S200 is specifically designed and highly recommended for the characterization of wafer sizes from 2" to 8 ", full or partial wafers. Pegasus ${ }^{T M}$ S200 offers rapid probing, with tunable speeds for specific applications.

All stages are controlled by the Pegasus ${ }^{\text {TM }}$ Controller consisting of the drive electronics, joystick, keypad and optional Windows user interface.

Interfacing is made easy with TTL, GPIB (IEEE488.2) and RS232 ports located on the back panel.

## USER FRIENDLY

Wentworth's Pegasus ${ }^{T M}$ S200 offers an Intuitive Menu-Driven Operation Interface with keypad and integrated or separate joystick.

User Interface includes:
$\checkmark$ Programmable Device Parameters.
$\checkmark$ Local Device File Storage.
$\checkmark$ Menu Driven User Interface.
$\checkmark$ Intelligent Theta Alignment.

## CHUCK SOLUTIONS

The Pegasus ${ }^{\text {TM }}$ S200 probe station can accomodate various vacuum chuck designs for full and partial wafers, providing users the ability to electrically ground, float or bias the chuck.

PEGASUS PROBE
Pegasus ${ }^{\text {TM }}$ Probe is an integrated wafer edge and height sensor and is commonly used on the Pegasus ${ }^{\text {TM }}$ S200. It combines both these functions into one compact unit and uses a open loop control system to automatically adjust the chuck $Z$ height while probing - this is reffered to as Active Wafer Profiling (AWR).

## ACTIVE WAFER PROFILING

The Pegasus ${ }^{\text {TM }}$ S200 probe station supports Active Wafer Profiling which produces repeatable probe marks accross the full wafer - an important advantage when probing for Known Good Die (KGD). Variable contact force adjustment makes it easy to obtain the desired probe mark and throughput.


Over-travel is applied from the point where the sensor has detected the surface. Parameters can be easily configured by user.

Same principle applies for probe cards using an edge sensor(s).


Pegasus ${ }^{\text {TM }}$ S200 with intergrated keypad/joystick.


Pegasus ${ }^{\text {TM }}$ S200 with ShieldMasterTM

## EASY CONTROL

Wentworth's Pegasus ${ }^{\text {TM }}$ S200 is designed with the operator in mind. Ergonomic design and controls make the S200 platform one of the easiest prober platforms on the market to use. Quick start up and simple menu's allow users to be probing in minutes.

The Wentworth Pegasus ${ }^{\text {TM }}$ S200 can be used in 'local' mode or 'remote' mode. This flexability allows the prober to be easily integrated with industry standard testers and data acquisition software.

## VERSATILITY

The Wentworth Pegasus ${ }^{\text {TM }}$ S200 can be configured for a variety of applications at affordable cost. Wentworth's many years of experience serving the electronics industry allows even the most challenging application to be managed within standard lead times and budget's.

## ROBUST DESIGN

Combining stainless steel and aluminium in it's construction the Pegasus ${ }^{\text {TM }}$ S200FA prober is extremely stable platform for sub micron probing and precision applications such as Laser cutting.

Lightweight chucks and drive mechanics allow extremely fast probing with no loss of accuracy.

## THERMAL CHARACTERIZATION

Wentworth offer performance thermal chuck solutions for device testing from -40oC to +300 C . Wentworth's propriety Heating and Cooling management system is an integral part of ShieldMaster ${ }^{T M}$, a localised light and/or safety enclosure.


| PEGASUS ${ }^{\text {TM }}$ S 200 SEMI-AUTOMATIC PROBE STATION |  |
| :---: | :---: |
| Chuck Stage |  |
| X-Y Stage |  |
| High precision ball-screws and stepper motors |  |
| Travel | $210 \times 210 \mathrm{~mm}$ |
| Resolution | $1.25 \mu \mathrm{~m}$ |
| Repeatability | $\pm 4.0 \mu \mathrm{~m}$ |
| Accuracy | $\pm 7.0 \mu \mathrm{~m}$ |
| Planarity | $8 \mu \mathrm{~m}$ |
| Maximum speed | $100 \mathrm{~mm} / \mathrm{sec}$ |
| Z Stage |  |
| Precision ball-screws and stepper motors |  |
| Travel | 11 mm |
| Resolution | $1 \mu \mathrm{~m}$ |
| Repeatability | $\pm 1.0 \mu \mathrm{~m}$ |
| Theta Stage |  |
| Travel | $\pm 8.0^{\circ}$ |
| Resolution | $0.0001^{\circ}$ |
| Probe Platform |  |
| Drive type | Manual |
| Z Travel | 11.5 mm |
| Material | Nickel Plated Steel |
| Graphical User Interface |  |
| Windows 7, 8.1 and 10 |  |
| Communication Interfaces |  |
| PC | TTL, RS232, GPIB <br> (IEEE488.2), ETHERNET |
| Utilities |  |
| Power | $100-240$ VAC $50 / 60 \mathrm{~Hz}$ auto select 600VA |
| Vacuum | 0.5 cfm @ 20 " Hg (min) |
| Compressed air | 4 bar min |
| Dimensions (WxDxH) |  |
| Prober (excludes optics) | $\begin{array}{r} 572 \times 700 \times 300 \mathrm{~mm} \\ 33 \times 32 \times 34^{\prime \prime} \end{array}$ |
| Controller | $\begin{gathered} 450 \times 480 \times 180 \mathrm{~mm} \\ 17.5 \times 19.5 \times 7^{\prime \prime} \end{gathered}$ |
| Shielding |  |
| Light | > 120 db |
| EMI | $>20 \mathrm{db} 0.05-0.5 \mathrm{Ghz}, 30 \mathrm{db}, \begin{gathered} 0.5-30 \mathrm{Ghz} \end{gathered}$ |
| Weight |  |
| Prober | 45 kg |
| Controller | 13 kg |

UNITED KINGDOM / EUROPE
Wentworth
Laboratories Ltd
1 Gosforth Close
Sandy, Bedfordshire SG19 1RB
England
Tel: +44 1767681221
Fax: +441767691951
Email:
CustomerServicesUK@ wentworthlabs.com

## UNITED STATES

Wentworth
Laboratories Litd
1087 Federal Road
Unit 4, Brookfield,
Connecticut 06804
Tel: 2037750448
Fax: 2037407636
Email:
CustomerServiceDeptCT@
wentworthlabs.com
BELGIUM/
NETHERLANDS
cyrood
1 Reasearchpark 40
1731 Zellik, Belgium
Tel: +32 (0) 24670350
Email:
sbuelens@cnrood.com
FRANCE, ITALY,
MOROCCO \& MALTA
STi
4 Rue des Beaumonts
$94 \wedge 20$ Fontenay-sous-bois
Paris
France
Tel: $+33(0) 1439400.99$
Email: info@stifranc
com

## POLAND

Testpol Sp. z.o.o ul.Klecinska 125, 54-413 Wroclaw, Poland
Tel: +48 717836360
Email: testpol@testpol.
com.pl

## ISRAEL

DANEL Technologies Ltd
58, Amal Street
Kirat Ari Petach Tikva, Israel
Tel: +972 (0) 39271888
1666
Email: sales@danel.co.il
INDIA
Electronic Enterprises PVT Ltd
No 12 1st Floor 3rd Main Road, Shivnagar, West of
Chord Road, Bangalore 560010, India
Tel: +91 0803380451

## Email:

eehyd@hotmail.com

## CHINA

Quatek Inc.
Unit 2112, 21F Yong Sheng Towers,
2025 West Zhong Shan Road
Shanghai, P.R.C (P.C. 200235)

Tel: +86-21-6481-3366 Email:
sales@quatek.com.cn
TAIWAN
Quatek Co. Ltd
4/F, 308, Sec. 1 Nei Hu Road, Nei Hu, Taipei 11493, Taiwan, R.O.C.
Tel: 886227973357
Fax: 886227973957

